



JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application:	Tomoo Yamasaki et al.	}	GRP ART UNIT: 2823
		}	
Serial No:	10/776,864	}	Ex.: Coleman, William D.
		}	
Filed:	February 10, 2004	}	
		}	
For:	Substrate Fabrication Method and Substrate		

Mail Stop Amendment
The Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Certificate of First Class Mailing

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Mail Stop: Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

August 11, 2005
Date

M. Pomroy
Maggie Pomroy

AMENDMENT

Sir:

In response to the Office Action mailed May 17, 2005 for the above-identified patent application, please amend the application as follows:

Amendments to the Drawings begin on page 2 of this paper and include an attached replacement sheet and an attached annotated sheet showing the revisions.

Remarks/Argument begin on page 3 of this paper.